

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yoshinobu KIMURA, et al.
Serial No.: 10/019,407
Filed: March 25, 2002
For: POLYCRYSTALLINE SEMICONDUCTOR THIN FILM
SUBSTRATE, MANUFACTURING METHOD OF THE
SAME, SEMICONDUCTOR DEVICE AND ELECTRONIC
DEVICE
Group: 2813
Examiner: Laura M. Schillinger

PETITION FOR EXTENSION OF TIME

Mail Stop: EOT/Appeal
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 11, 2008

Sir:

In the matter of the above-identified application, Applicants hereby respectfully petition for an extension of time to permit filing a Notice of Appeal within a two-month time period subsequent to expiration of the response period set with the mailing of the Final Office Action, dated September 10, 2007. A credit card authorization in the amount of \$460.00 to cover the required fee for the requested extension of time and \$510.00 for the Notice of Appeal fee is also submitted.

It is respectfully requested that any shortage in the fees be charged to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (Docket No. 520.41003X00) and any excess fees credited to that account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

By /Larry N. Anagnos/
Larry N. Anagnos, Reg. No. 32,392
(703) 312-6600

LNA:dlh